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**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: Gerrit-Jan HEERENS et al.

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of

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Examiner: UNKNOWN

Group Art Unit: UNKNOWN

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR	4,610,020	09/1986	LA FIANDRA et al.			
	BR	6,172,738	01/2001	KORENAGA et al.			
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						

10/084656
10/084656
02/28/02

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract	Translation Readily Available
							Enclosed	No
	MR	0 789 280 A2	08/1997	EUROPE				
	NR	0 881 538 A2	12/1998	EUROPE				
	OR							
	PR							
	QR							
	RR							

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	SR	"Photomasks with Integral Laser Mirrors and Calibration of Integral Laser Mirrors on Photomasks," IBM Technical Disclosure Bulletin 32(5B):19-21 (October 1989)						
	TR	A copy of the European Search Report dated September 6, 2001, issued in the corresponding European Application No. EP 01 30 1864						
	UR							
	VR							
	WR							
	XR							
	YR							
	ZR							
	AAR							
	BBR							

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.